

Electronic Filing System (EFS) Data **Electronic Patent Application Submission USPTO** Use Only

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Application ID:

10630349

Title of Invention:

BEAM ELECTRON BEAM

ELECTRON OPTICS FOR MULTI-

LITHOGRAPHY TOOL

First Named Inventor:

N. PARKER

Domestic/Foreign Application: Domestic Application

Filing Date:

2003-07-29

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Information Disclosure

Statement

Filing Type:

Confirmation number:

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Attorney Docket Number:

58884-0305279

Total Fees Authorized:

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TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention

ELECTRON OPTICS FOR MULTI-BEAM ELECTRON BEAM LITHOGRAPHY TOOL

Application Number:

10/630349

Date:

2003-07-29

First Named Applicant:

N. WILLIAM PARKER

Confirmation Number:

9297

Attorney Docket Number: 58884-0305279

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Submitted by:	Elec. Sign.	Sign. Capacity
DAVID H. JAFFER Registered Number: 32,243	/David H. Jaffer/	Attorney

Documents being submitted

Files

us-ids

058884-0305279-usidst.xml

us-ids.dtd

us-ids.xsl

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

Title of Invention

ELECTRON OPTICS FOR MULTI-BEAM ELECTRON **BEAM LITHOGRAPHY TOOL**

Application Number:

10/630349

Confirmation Number:

9297

First Named Applicant:

N. PARKER

Attorney Docket Number: 58884-0305279

Art Unit:

2881

Search string:

(6509750 or 6465783 or 6252412 or 6157039 or 6023060 or 5981962 or 5892224 or 5578821 or 5557105 or 5502306 or 5430292 or 5384463 or 5363021 or 4996441 or 4902898 or 4724328 or 4742234 or 4694178 or 4661709 or 4430571

or 4390789).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
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Signature

Examiner Name	Date